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*IPW*  
*AF/1762*

**AMENDMENT UNDER 37 C.F.R. § 1.116**  
**EXPEDITED PROSECUTION - GROUP ART UNIT 1762**

03500.014241

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
NOBUHIRO ITO ) Examiner: B. Talbot  
Application No.: 09/505,627 ) Group Art Unit: 1762  
Filed: February 16, 2000 )  
For: MANUFACTURING METHOD OF )  
ELECTRON BEAM APPARATUS )  
AND SPACER, AND ELECTRON )  
BEAM APPARATUS ) August 19, 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Mail Stop AF

**AMENDMENT AFTER FINAL REJECTION**

Sir:

**A. Introductory Comments**

In response to the final Office Action dated May 20, 2004, please amend the application as follows and consider the following remarks.